Attorney Docket: 081468-0354685 Client Reference: P-1775.010-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 8421

THEODORUS MARINUS MODDERMAN ET AL.

Application No.: 10/583,985

Group Art Unit: 2877

Filed: June 4, 2007

Examiner: UNKNOWN

Title: LITHOGRAPHIC APPARATUS, METHOD OF EXPOSING A SUBSTRATE, METHOD OF MEASUREMENT, DEVICE MANUFACTURING METHOD, AND DEVICE MANUFACTURED

THEREBY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

Attached is a copy of the official filing receipt from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested. There is an error with respect to the following data which is incorrectly entered.

Error in

Correct data

Title

LITHOGRAPHIC APPARATUS, METHOD OF EXPOSING A SUBSTRATE, METHOD OF MEASUREMENT, DEVICE MANUFACTURING METHOD, AND DEVICE MANUFACTURED THEREBY

Respectfully submitted,

PILLSBURY WINTHROP SHAW PITTMAN LLP

Róbert C./Perez Reg. No. 39328

Tel. No. (703) 770-7900 Fax No. (703) 770-7901

Date: December 18, 2007

P.O. Box 10500 McLean, VA 22102

Customer Number: 00909



United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS Dox 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

| | APPL NO. | FILING OR 371(c) DATE | ART UNIT | FIL FEE REC'D | ATTY.DOCKET NO | TOT CLMS | IND CLMS |
|---|------------|--------------------------|----------|---------------|----------------|----------|----------|
| _ | 10/583 085 | 06/04/2007 | 2877 | 3390 | 091469 0354695 | E 1 | 7 |

CONFIRMATION NO. 8421 FILING RECEIPT

OC000000024954695

Date Mailed: 07/24/2007

909 PILLSBURY WINTHROP SHAW PITTMAN, LLP P.O. BOX 10500 MCLEAN, VA 22102

Receipt is acknowledged of this nonprovisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Theodorus Marinus Modderman, Nuenen NETHERLANDS; Nicolaas Antonius Allegondus Johannes Van Asten, Breda, NETHERLANDS; Johan Maria Van Boxmeer, Sint Oedenrode, NETHERLANDS; Gerrit Johannes Nijmeijer, Eindhoven, NETHERLANDS;

Assignment For Published Patent Application

ASML Netherlands B.V., Veldhoven, NETHERLANDS

Power of Attorney: The patent practitioners associated with Customer Number 00909

PILLSBURY WINTHROP SHAW PITTMAN

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/NL04/00900 12/22/2004

JUL 2 5 2007

DUE: DKT BY(1

Foreign Applications

If Required, Foreign Filing License Granted: 07/20/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/583,985**

Projected Publication Date: 11/01/2007

Non-Publication Request: No

Early Publication Request: No

Title

Lithographic Apparatus, Method of Exposing a Substrate, Method of Measurement, Device Manufacturing Method, and Device Manufacturing Thereby

Manufactured

Preliminary Class

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